# Photoresponse of Graphene-gated Graphene-GaSe Heterojunction Devices

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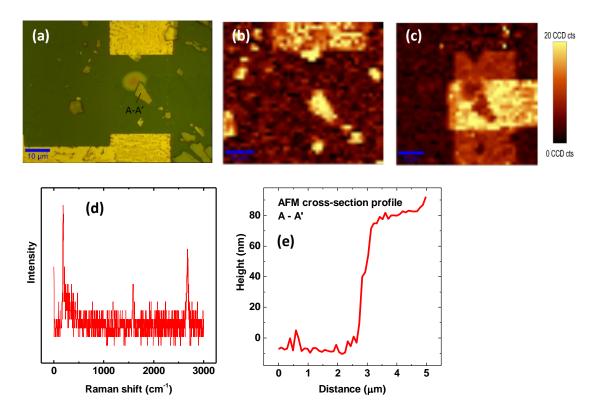
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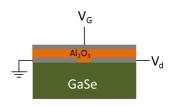
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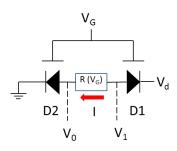
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## 1. Device I



**Figure S-1**. Device I. (a) Optical image and Raman map for the peak of (b) GaSe appearing at  $\sim 212 \text{ cm}^{-1} (E_{2g}^1)$  and of (c) the graphene at  $\sim 2680 \text{ cm}^{-1} (2D)$ . (d) Raman spectra corresponding to the point of the S/D area. (e) Height profile measured by AFM along the A-A' line in (a).





#### **Diode equations**

$I_2 = I_o exp(-\phi_{b2}/kT)exp(qV_0/\eta_2kT)(1-exp(-qV_0/kT))$
$I_1 = I_o \exp(-\phi_{b1}/kT) \exp(q(V_1 - V_d)/\eta_1 kT)(1 - \exp(-q(V_1 - V_d)/kT))$

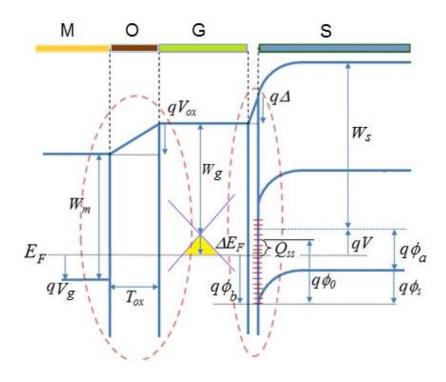
#### **Circuit laws**

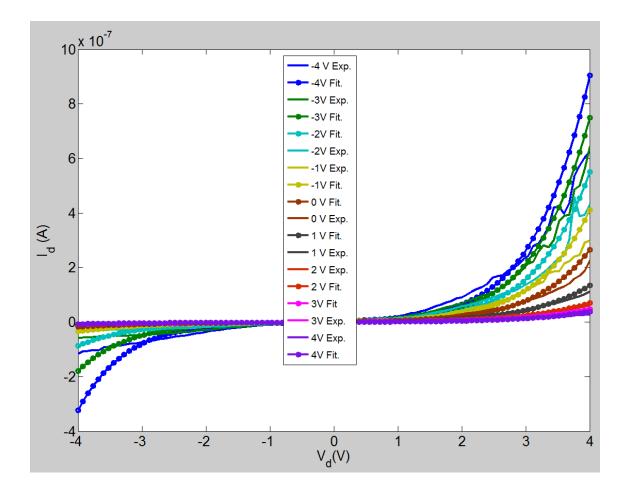
 $-I_1=I_2=I$  $V_1-V_0=IR$ 

#### Remark

 $\phi_{b1}$  and  $\phi_{b2}$  are determined following the procedure in Refs. (24) and (35) in the main text, taking into account possible Fermi level pinning.

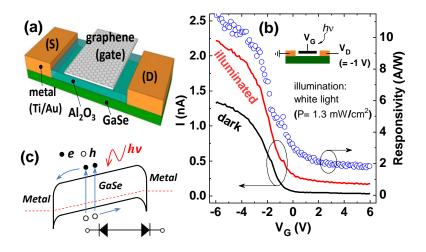
#### Band diagram of the MOGS heterostructure





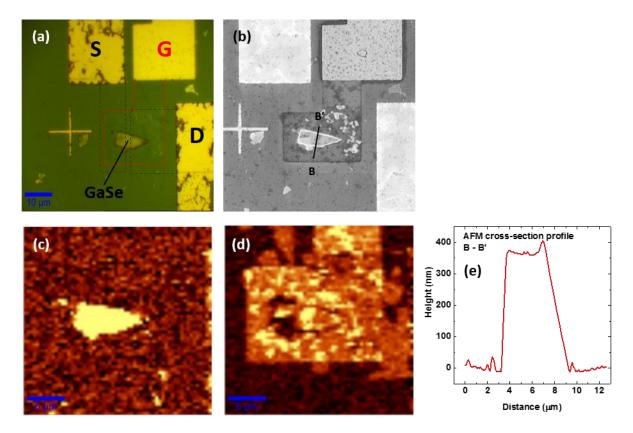
**Figure S-2**. Device I. Simulations for the output characteristics. (upper) Schematics of the device model and equivalent circuitries. (middle) Band diagram of the MOGS heterostructure indicating the Schottky Barrier Height  $\phi_b$ . (lower) Simulated I-V characteristics with varied V<sub>G</sub> in sweeping of V<sub>D</sub> from -4 to 4 V, performed using the parameters and equations above.

#### 2. Graphene gated metal-GaSe-metal FET

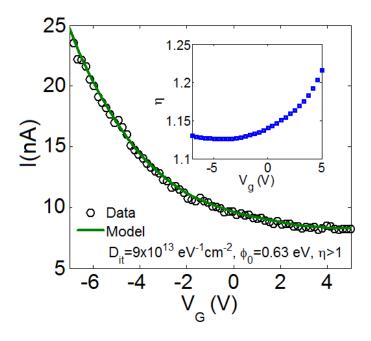


**Figure S-3**. (a) Schematic of graphene gated GaSe FET. (b) (left axis) Transfer characteristics of the device measured at  $V_D$ = -1 V. A black and red lines denote the currents measured in dark and under illumination (white light, P= 0.16 mW). (right axis) Corresponding photo-responsivity (=  $I_{ph}/P_{channel}$ ) plotted with blue circles along V<sub>G</sub>. The inset describes the cross-section view of device with electrical configuration. hv is the incident light energy. (c) Band diagram describing the photocurrent generation process in hole transport when the device is biased, including equivalent circuitry (back-to-back diode configuration).

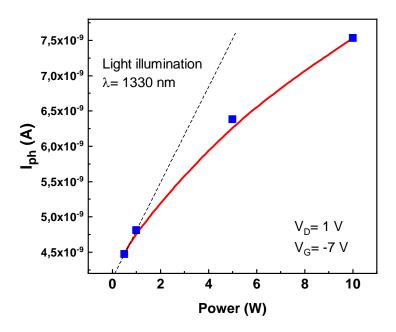
## 3. Device II



**Figure S-4.** Device II. (a-b) Optical and SEM image of the device. Dashed lines in black and red denote a graphene contact and a topgate, respectively. (c-d) Raman map for the peak of (c) GaSe appearing at ~212 cm<sup>-1</sup> ( $E^{1}_{2g}$ ) and (d) of the graphene at ~2680 cm<sup>-1</sup> (2D). (e) Height profile measured by AFM along the B-B' line in (b).

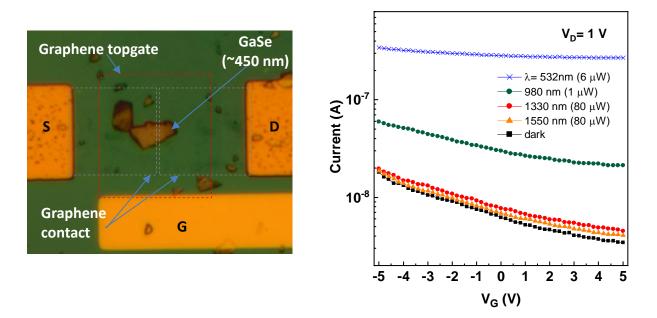


**Figure S-5**. Device II. Simulated transfer characteristics. The best fit to the measurements is reached when  $D_{it} \sim 10^{14} \text{ eV}^{-1} \text{cm}^{-2}$  and  $\phi_0 \sim E_g/3$  are assumed. To gain consistency with the experiment we have considered an ideality factor that depends on the gate bias, as shown in the inset.

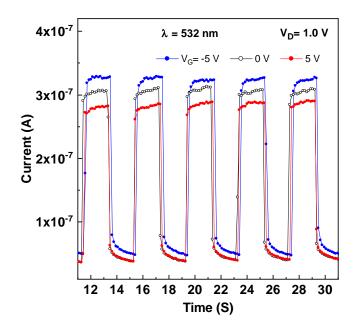


**Figure S-6.** Device II. Photogenerated current versus illuminated power at 1330 nm. The red line is a curve fitted to data obtained with the power (P)= 0.5, 1, 5, 10 mW. The trend of linear curve-fit to points for P= 0.5 and 1 mW is shown with a dotted line.

### 4. Device III

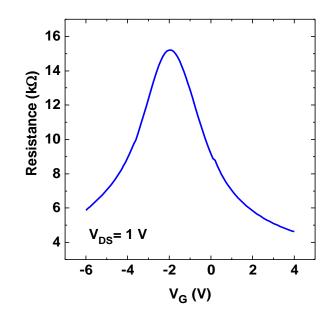


**Figure S-7**. Device III. (left) optical image of graphene-gated graphene-GaSe heterojuction structure. The channel size (width x length) of GaSe is  $6 \times 1 \mu m^2$ . (right) Transfer characteristics of the device under illumination.



**Figure S-8**. Device III. Time-resolved photo-response of the device at 532 nm. Different colors denote the different gate voltages applied under illumination.

## 5. Graphene property



**Figure S-9**. Graphene FET. Total resistance versus V<sub>G</sub>. Graphene is slightly n-type doped. The channel size of the graphene FET (width × length) is  $30 \times 30 \ \mu m^2$ .